



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	)	
	)	
YANG, Nian, et al.	)	Examiner: PHAM, Long
	)	
Serial No. 10/758,148	)	Group Art Unit: 2814
	)	
Filing Date: January 14, 2004	)	Confirmation No. 4639
	)	
For: EFFICIENT USE OF	)	
WAFER AREA WITH	)	
DEVICE UNDER THE PAD	)	
APPROACH	)	
	)	

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**AMENDMENT AND REQUEST FOR CONTINUING EXAMINATION  
(RCE)**

Hon. Assistant Commissioner for Patents  
P.O. Box No. 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed on November 29, 2005, please amend the above captioned patent application as follows and consider the following remarks. Applicants respectfully request continuing examination.

There are no amendments to the specification in this responsive paper. The Amendments to the Claims are reflected in the listing of the Claims, which begins on page 2 of this responsive paper. The Remarks, with arguments, begin on page 5 of this responsive paper.